IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MAIL STOP PATENT APPLICATION Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

CERTI	MOATE UNDER 37	
I hereby certify that this as attached therein are t		nd the documents referred to
		al Service in an envelope as ee," mailing label No. EV
349852452 US addre	essed to: Mail	Stop Patent Application
Commissioner for Paten		Alexandria, VA 22313-1450.

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Inventor(s):

ITO, Hiroyuki; MATSUNAGA, Yasuhiko

Title:

Ion Implantation Method, SOI Wafer Manufacturing Method and Ion

Implantation System

Transmitted herewith is the patent application identified above, including:

23 Total Pages

 \boxtimes Drawings X Formal ☐ Informal

8 Total Pages

 \boxtimes **Executed Combined Declaration and Power of Attorney**

Claim to Priority 冈

Certified priority document, JP 2002-223614

FEE CALCULATION (37 CFR 1.16)

	NUMBER OF CLAIMS FILED	LESS NUMBER PAID BY BASIC FEE	NUMBER OF EXTRA CLAIMS (Not less than zero)	LARGE ENTITY FEE
Basic Fee				\$750.00
Total Claims	19	- 20 =	X \$18 =	\$0.00
Independent Claims	2	- 3 =	X \$84 =	\$0.00
First Presentation	-0-			
in .	\$750.00			

- \boxtimes The Commissioner is hereby authorized to charge \$750.00 to Deposit Account No. 20-0782 SOEI/0057. A duplicate copy of this transmittal is enclosed.
- \boxtimes The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 20-0782/SOEI/0057. A duplicate copy of this transmittal is enclosed.
- X Please address all future correspondence to:

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